NOV 2 3 2004 5 Express Mail Label No. EV 607628304 US 17 W 500

PATENT APPLICATION Docket No: 11675.73.1.2.1

#### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of		)
	Yongjun Hu	)
Serial No.:	10/771,828	) Art Unit
Confirmation No.:	3960	) 2818
Filed:	February 4, 2004	)
For:	PROCESS FOR FORMING A DIFFUSION BARRIER MATERIAL NITRIDE FILM	) ) )

## <u>UNDER 37 C.F.R. § 1.97</u>

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Please find, pursuant to 37 C.F.R. § 1.98(a)(1), the enclosed Form PTO-1449 which contains a list of all patents, publications, or other items that have come to the attention of one or more of the individuals designated in 37 C.F.R. § 1.56(c). While no representation is made that any of these references may be "prior art" within the meaning of that term under 35 U.S.C. §§ 102 or 103, the enclosed list of references is disclosed so as to fully comply with the duty of

disclosure set forth in 37 C.F.R. § 1.56.

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Moreover, while no representation is made that a specific search of office files or patent office records has been conducted or that no better art exists, the undersigned attorney of record believes that the enclosed art is the closest to the claimed invention (taken in its entirety) of which the undersigned is presently aware, and no art which is closer to the claimed invention (taken in its entirety) has been knowingly withheld.

In accordance with 37 C.F.R. §§ 1.97 and 1.98, a copy of each of the listed references or relevant portion thereof that is not a U.S. Patent document is also enclosed.

DATED this 23 day of November 2004.

Respectfully submitted,

Gregory M. Taylor

Attorney for Applicant Registration No. 34,263

Customer No. 022901

Telephone No. (801) 533-9800

GMT: gpm GPM0000000278V001

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<u>T</u>	RANSMITTAI	L FOR INFORMATION DISCLOSURE	<u>STATEMENT</u>
Mail Stop Am Commissione P.O. Box 145 Alexandria, V	r for Patents		
Sir:			
	atement, which	n for filing and pursuant to 37 C.F.R. includes the following statements, if any	•
	Statement of which are not	relevance of selected cited references no translated.	ot in the English language
		at selected cited references are substate reviously submitted reference.	intially cumulative of an
	the United St	t selected cited references were previous ates Patent and Trademark Office in a r an earlier filing date under 35 U.S.C. §	prior application which is

### A. Additional Materials Required Due to Content of Information Disclosure Statement

Transmitted are the following documents in addition to the Information Disclosure Statement as required variously under 37 C.F.R. § 1.98:

Page 2

Attorney for Applicant Registration No. 34,263 Customer No. 022901

Telephone No. (801) 533-9800

GMT:gpm Enclosures GPM0000000279V001 Form PTO-1449

Sheet 1 of 3

Applicant:

Yongjun Hu 10/771,828

Att'y Docket No.: 11675.73.1.2.1

Confirmation No.: 3960

Serial No.: Filing Date:

February 4, 2004

Group: 2818

PROCESS FOR FORMING A DIFFUSION BARRIER MATERIAL NITRIDE FILM

#### INFORMATION DISCLOSURE CITATIONS MADE BY APPLICANT

#### U.S. Patent Documents

Ripping			
Examiner	Document	Issue	
<u>Initial*</u>	Number	<u>Date</u>	<u>Name</u>
1	4,782,380	11/01/88	Shankar et al.
2	4,847,111	07/11/89	Chow et al.
3	4,897,368	01/30/90	Kobushi et al.
4	4,927,505	05/22/90	Sharma et al.
5	4,976,839	12/11/90	Inoue
6	5,075,251	12/24/91	Torres et al.
7	5,162,262	11/10/92	Ajika et al.
8	5,188,979	02/23/93	Filipiak
9	5,286,676	02/15/94	Kruger et al.
10	5,318,924	06/07/94	Lin et al.
11	5,631,479	05/97	Shiga
12	5,633,200	05/27/97	Hu
13	5,665,209	09/09/97	Byun
14	5,688,718	11/18/97	Shue
15	6,080,657	06/27/00	Liu et al.
16	6,472,264 B1	10/29/02	Agarwal
17	6,489,194 B1	12/03/02	Agarwal

Examiner:

Date Considered:

<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609, draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form PTO-1449

Sheet 2 of 3
Hu Confirmation No.: 3960

Applicant: Serial No.:

Yongjun Hu 10/771,828

Att'y Docket No.: 11675.73.1.2.1

Filing Date:

February 4, 2004

Group: 2818

For:

PROCESS FOR FORMING A DIFFUSION BARRIER MATERIAL NITRIDE FILM

		Earsign Patent Desuments		
•		Foreign Patent Documents		
Examiner <u>Initial</u> *	Document Number	PublicationDate	Country or Patent Office	Translation
18	3-11735 (A)	01/21/91	Japan	no
19	5-347274 (A)	12/27/93	Japan	no
		Other Documents		
	(inclu	ding author, title, pertinent pages, etc.	)	
Examiner Initial*				
20		act Filling and Planarization W lings ULSI-VII, pp. 535-540, 19		rials Research
21	Shingubara S. et al, Submicron Hole Filling Characteristics Employing ECR A1 Sputtering with High Magnetic Field, Materials Research Society, Conference Proceedings ULSI-VIII, p. 257-266, 1993.			
22	Joshi R.V. et al., Collimated Sputtering for Refractory Metal Liners for Sub-Half Micron Technology, Materials Research Society, Conference Proceedings ULSI-VIII, pp. 273-279, 1993.			
23	Hsieh J. J. et al., Collimated Liners: Process Modeling and Material Characteristics, Materials Research Society, Conference Proceedings ULSI-IX, pp. 207-213, 1994.			
24	Ramaswami S. et al., Development of a Coherent Ti/TiN Processs for Sub-Half Micron Technologies, Materials Research Society, Conference Proceedings ULSI-IX, pp. 215-221, 1994.			

#### References Cited by Applicants

While the filing of Information Disclosure Statements is voluntary, the procedure is governed by the guidelines of Section 609 of the Manual of Patent Examining Procedure and 37 C.F.R. §§ 1.97 and 1.98. To be considered a proper Information Disclosure Statement, Form PTO-1449 shall be accompanied by a copy of each listed patent or publication or other item of information and a translation of the pertinent portions of foreign documents (if an existing translation is readily available to the applicant), an explanation of relevance of each reference not in the English language, and should be submitted in a timely manner as set out in MPEP Sec. 609.

Examiner:	Date Considered:	

<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609, draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form PTO-1449

Yongjun Hu Applicant: 10/771,828

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Confirmation No.: 3960 Att'y Docket No.: 11675.73.1.2.1

Group: 2818

Sheet 3 of 3

PROCESS FOR FORMING A DIFFUSION BARRIER MATERIAL NITRIDE FILM For:

Examiners will consider all citations submitted in conformance with 37 C.F.R. § 1.98 and MPEP Sec. 609 and place their initials adjacent the citations in the spaces provided on this form. Examiners will also initial citations not in conformance with the guidelines which may have been considered. A reference may be considered by the Examiner for any reason whether or not the citation is in full conformance with the guidelines. A line will be drawn through a citation if it is not in conformance with the guidelines AND has not been considered. A copy of the submitted form, as reviewed by the Examiner, will be returned to the applicant with the next communication. The original of the form will be entered into the application file.

Each citation initialed by the Examiner will be printed on the issued patent in the same manner as references cited by the Examiner on Form PTO-892.

The reference designations "A1," "A2," etc. (referring to Applicant's reference 1, Applicant's reference 2, etc.) will be used by the Examiner in the same manner as Examiner's reference designations "A," "B," "C," etc. on Office Action Form PTO-1142.

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Examiner:	Date Considered:

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#### CERTIFICATE OF EXPRESS MAIL UNDER 37 C.F.R. § 1.10

I hereby certify that the following documents are being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 C.F.R § 1.10 in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 23 day of November 2004:

- Transmittal for Information Disclosure Statement
- Information Disclosure Statement
- Form PTO-1449
- Copies of references
- Credit Card Payment Form PTO-2038 for \$180.00
- Postcard

Respectfully submitted,

Gregory M Yaylor Attorney for Applicant

Registration No. 34,263

Customer No. 022901

Telephone No. (801) 533-9800

GMT:gpm GPM0000000279V001